

<b>Notice of References Cited</b>	Application/Control No. 10/772,673	Applicant(s)/Patent Under Reexamination KUZMIK, JAN	
	Examiner Johannes P Mondt	Art Unit 2826	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,554,865	09-1996	Larson, Lawrence E.	257/275
*	B	US-6,242,766	06-2001	Tateno, Yasunori	257/194
*	C	US-6,727,531	04-2004	Redwing et al.	257/194
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	EP 0 606 776 A2	07-1994	Europe	White, Julian Darryn	H01L 31/09
	O	JP-08186450 A	07-1996	Japan	Kawasaki, Kenichi	H03D 7/00
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Kim, K.S., et al: "Determination of the band-gap energy of Al <sub>1-x</sub> In <sub>x</sub> N grown by metal-organic chemical-vapor deposition, Applie Physics Letters, Vol. 71 (issue 6), pp. 800-802
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.